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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Buchanan, Robert; Yarussi, Richard A.; Spady, Blaine R.
Assignee: Nanometrics Incorporated
Title: SYSTEM USING A POLAR COORDINATE STAGE AND
CONTINUOUS IMAGE ROTATION TO COMPENSATE FOR STAGE
ROTATION
Serial No.: 09/113,484 Filed: 07/10/98
Examiner: Unknown Group Art Unit: Unknown
Docket No.: M-5955 US

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ASSISTANT COMMISSIONER FOR PATENTS
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**INFORMATION DISCLOSURE STATEMENT WITH
CERTIFICATION UNDER § 1.97(e)(1)**

Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicants wish to call the following documents (copies enclosed) to the attention of the Examiner. The documents were cited in the enclosed European Search Report for the corresponding European Application No. 99305471.7:

1. Judell et al. (4,457,664)
2. Egan (4,907,880)
3. Bacchi et al. (5,646,776)

A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or

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SER. NO. 09/113,484

3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

The undersigned hereby certifies in accordance with § 1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: ASSISTANT COMMISSIONER FOR PATENTS, Washington, D.C. 20231, on March 8, 2000.

David Millers 3-8-00
Attorney for Applicants Date of Signature

Respectfully submitted,

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